

Search Notes



Application/Control No.

10/798,000

Examiner

Stephen M. Hepperle

Applicant(s)/Patent under Reexamination

EJIRI, TAKASHI

Art Unit

3753

SEARCHED

Class	Subclass	Date	Examiner
137	505.29 505.32 505.3	4/06	SMA
	505.34 505.35		
	505.39		

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
EAST	4/06	SMA